Sheet 1 of 1

LIST OF CITATIONS BY APPLICANT (Use several sheets if necessary)	Atty. Docket No. 1780A1	10/627,775
	Applicant Stuart D. Hellring, et al.	
	Filing Date July 28, 2003	Group

## U.S. PATENT DOCUMENTS

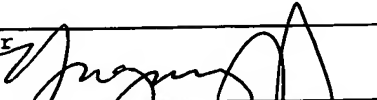
Exam. Init.		Document No.	Date	Name	Class	Subclass	Filing Date if appropriate
GN	AA	5,720,551	02/24/98	Tal Shechter	366	147	
GN	AB	US2003/0094 593A1	05/22/03	Stuart D. Hellring, et al.	252	79.1	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation Yes No	
GN	AL	WO 00/39056	06.07.00	PCT				X
	AM							
	AN							
	AO							
	AP							

## OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

GN	AR	U.S. Serial No. 09/882,548 filed 06/14/01 "A SILICA-BASED SLURRY"
	AS	
	AT	

Examiner 	Date Considered 12/06/04
--	-----------------------------

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

		Atty. Docket No. 1780A1	Serial No. 10/627,775
LIST OF CITATIONS BY APPLICANT (Use several sheets if necessary)		Applicant: Stuart D. Hellring, et al.	
		Filing Date: July 28, 2003	Group Art Unit: 3723

## U.S. PATENT DOCUMENTS

Init.		Document No.	Date	Name	Class	Subclass	Filing Date if appropriate
GN	AA	5,885,334	03/23/99	Tetsuo and Hara	<del>406</del>	<del>3</del>	
↓	AB	5,954,975	09/21/99	Cadien and Feller	<del>216</del>	<del>38</del>	
GN	AC	5,985,748	11/16/99	Watts, et al.	<del>438</del>	<del>622</del>	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation Yes	No
GN	AL	EP 0 684 634 A2	04.05.1995	EP				
↓	AM	EP 1 085 067 A1	30.11.1999	EP				
↓	AN	WO 00/00561	06.01.2000	PCT				
↓	AO	WO 01/78128 A2	18.10.2001	PCT				
GN	AP	WO 02/102920 A1	27.12.2002	PCT				

## OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

GN	AR	US 2002/0068451 A1, Semiconductor Device Production Method, June 6, 2002
	AS	
	AT	

Examiner 	Date Considered 12/06/04
--	--------------------------

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.  
SUBSTITUTE DISCLOSURE STATEMENT FORM (PTO 1449)